



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 14, 2025

IGI Report Number **LG743518177**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **13.71 X 7.14 X 4.43 MM**

GRADING RESULTS

Carat Weight **2.90 CARATS**

Color Grade **D**

Clarity Grade **VVS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG743518177**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG743518177
Report verification at igi.org

LABORATORY GROWN DIAMOND REPORT



October 14, 2025

IGI Report Number

LG743518177

Description **LABORATORY GROWN DIAMOND**

OVAL BRILLIANT

Shape and Cutting Style **OVAL BRILLIANT**

13.71 X 7.14 X 4.43 MM

GRADING RESULTS

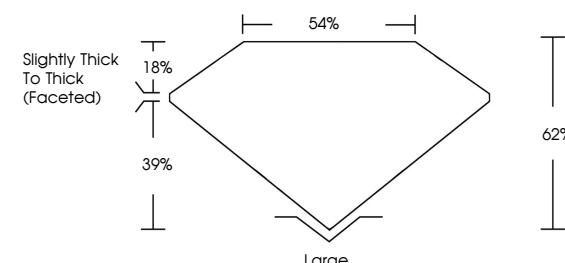
Carat Weight **2.90 CARATS**

D

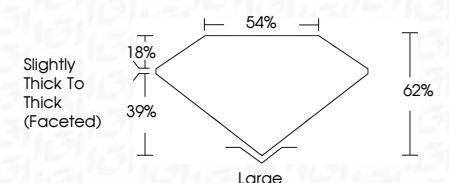
Color Grade **VVS 1**

Clarity Grade

PROPORTIONS



Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
---	---	---	---	---	---	---	-------	------------	-------

CLARITY

FL	IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
----	----	-------------------	-------------------	-------------------	------------------

Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
----------	---------------------	-----------------------------	------------------------	-------------------	----------

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG743518177**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa



FD - 10 20

www.igi.org



THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.



Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa